



Disclosure No. 03-1044.00/US

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Gealy et al.

Application No.: 10/814,573

Filed: March 31, 2004

AMPOULES FOR PRODUCING A For:

> REACTION GAS AND SYSTEMS FOR DEPOSITING MATERIALS ONTO MICROFEATURE WORKPIECES IN

REACTION CHAMBERS

Confirmation No.: 6920

Art Unit: 1763

Examiner: R. R. Bueker

## **INFORMATION DISCLOSURE STATEMENT (IDS)**

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A copy of each Non-U.S. Patent and each Non-Patent Literature article listed on the PTO/SB/08 is attached. A copy of the U.S. Patents listed on the PTO/SB/08 has not been A full translation of the non-English language references marked by a provided. check mark ( $\sqrt{}$ ) is enclosed. An abstract is enclosed for all other non-English language Application No.: 10/814,573 Docket No.: 108298765US

references. Applicant has not verified that the translation or abstract is an accurate representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298765US.

Dated: April 11, 2005

Respectfully submitted,

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PTO/SB/92 (09-04)

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Application No. (if known): 10/814,573

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10/814,573-Conf. #6920

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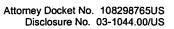
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Application Number

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## **TRANSMITTAL** March 31, 2004 First Named Inventor **FORM** Dan Gealy Art Unit 1763 (to be used for all correspondence after initial filing) **Examiner Name** R. R. Bueker Attorney Docket Number Total Number of Pages in This Submission 17\* 108298765US **ENCLOSURES** (Check all that apply) After Allowance Communication Fee Transmittal Form Drawing(s) Appeal Communication to Board of Licensing-related Papers Fee Attached Appeals and Interferences Appeal Communication to TC Petition Amendment/Reply (Appeal Notice, Brief, Reply Brief) Petition to Convert to a Proprietary Information After Final Provisional Application Power of Attorney, Revocation Status Letter Affidavits/declaration(s) Change of Correspondence Address X Other Enclosure(s) (please Identify below): Terminal Disclaimer **Extension of Time Request** Certificate of Mailing Request for Refund **Express Abandonment Request** Form PTO/SB/08 Cited References (64) x Information Disclosure Statement CD, Number of CD(s) Return Receipt Postcard Certified Copy of Priority Landscape Table on CD Document(s) Reply to Missing Parts/ Remarks Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Name PERKINS COIE LLP Signature Printed name David T. Dutcher Date Reg. No. 51,638 April 11, 2005

<sup>\*</sup> Number of pages does not include cited references





Substitute for form 1449A/B/PTO				Complete if Known		
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5	STATEMEN	T BY AP	PLICANT	First Named Inventor	Dan Gealy	
				Art Unit	1763	
	(Use as many sheets as necessary)			Examiner Name	Richard R. Bueker	
Sheet	1	of	13	Attomey Docket Number	108298765US	

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Examiner	Date	
Signature	Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.